# Optical vortex Iaser measurement 

## Yoshitaka Taira

National Institute of Advanced Industrial Science and Technology (AIST)

## Laser and CCD camera

Laser: World Star Tech
Wavelength: 532 nm
Power: < 5 mW
Beam size: $0.54 \mathrm{~mm}(\mathrm{H}), \mathbf{0 . 5 9 \mathrm { mm } ( \mathrm { V } ) \text { at FWHM }}$
Camera: COHU, Model 4812
Pixel size: $0.0135 \mathrm{~mm} / \mathrm{px}$
Pixel: 512 (H), 480 (V)



## Coordinate system



Coordinate system of the calculated result should be reversed to compare with the measurement results.

## Diffraction pattern

## Grating



OAM value $=m \times n$
( $m$ is the charge of grating, $n$ is the diffraction order )



## List of gratings

| Grating\# | Charge, m | Lines <br> /mm | Diff. angle <br> $(\mathrm{mrad})$ | Scat. angle <br> (mrad) |
| :--- | :--- | :--- | :--- | :--- |
| 27A | 1 | $30 \pm 2$ | $13.9 \pm 0.4$ | $1.8 \pm 0.3$ |
| 26A | 1 | $30 \pm 2$ | $14.7 \pm 0.1$ | $2.1 \pm 0.2$ |
| 24A | 2 | $30 \pm 2$ | $14.8 \pm 0.1$ | $2.2 \pm 0.3$ |
| 2A | 2 | $22 \pm 2$ | $10.6 \pm 0.1$ | $2.3 \pm 0.2$ |
| 34A | 3 | $30 \pm 2$ |  |  |
| 9A | 3 | $22 \pm 2$ |  | Charge, $m=2$ |
| 35A | 4 | $30 \pm 2$ |  |  |
| 10A | 4 | $22 \pm 2$ |  |  |
| 33A | 5 | $30 \pm 2$ |  |  |
| 11A | 5 | $22 \pm 2$ |  |  |
| 29A | 10 | $30 \pm 2$ |  |  |
|  |  |  |  |  |
| Lines per mm was measured with a |  |  |  |  |
| optical microscope and microscale. |  |  |  |  |

## Power measurement

Pin $=4.59 \mathrm{~mW}$
Power of diffracted beam ( $\mathrm{n}=0$ and $\mathrm{n}=1$ ) was measured.



Power of non diffracted beam increases as the Ipm is large.
Power of $\mathrm{n}=1$ beam increases as the Ipm in small (except 0AM =4) and differs even if same $0 A M$ value ( $0 A M=1$ ).

## Interference pattern measurement

1. $\mathbf{O A M}+$ reference $(R=215 \mathrm{~mm})$
2. OAM + reference $(R=\infty)$
3. OAM (double gratings) + reference $(\mathbf{R}=\mathbf{2 1 5} \mathrm{mm})$
4. OAM + OAM

## Interference pattern with lens

Reference light


## Interference pattern

OAM
value

Reference light
OAM light
Interference
$-1$

-2


## Calculation of interference pattern

Interference between two different electric fields

$$
\begin{aligned}
& E_{1} \exp \left(i \phi_{1}\right) \quad E_{2} \exp \left(i \phi_{2}\right) \\
& I=\mid E_{1} \exp \left(i \phi_{1}\right)+E_{2} \exp \left(i \phi_{2}\right)^{2}=E_{1}^{2}+E_{2}^{2}+2 E_{1} E_{2} \cos \left(\phi_{1}-\phi_{2}\right)
\end{aligned}
$$

## Gaussian beam (reference light)

$E=E_{0} \frac{\omega_{0}}{\omega(z)} \exp \left(-\frac{r^{2}}{\omega^{2}(z)}\right) \exp \left\{-i\left(k z+k \frac{r^{2}}{2 R(z)}-\psi(z)\right)\right\}$
$\omega(z)=\omega_{0} \sqrt{1+\left(\frac{z}{z_{R}}\right)^{2}} \quad$ Beam radius
$R(z)=z\left\{1+\left(\frac{z_{R}}{z}\right)^{2}\right\} \quad$ Rradius of curvature of the beam's wavefront
$z_{R}=\frac{\pi \omega_{0}^{2}}{\lambda} \quad$ Rayleigh range
$\psi(z)=\tan ^{-1}\left(\frac{z}{z_{R}}\right) \quad$ Gouy phase
$\omega_{0}=0.053 \mathrm{~mm} \quad$ Waist size when the laser is focused by a f100 lens

## Laguerre Gaussian beam (OAM light)

$$
\begin{aligned}
E= & \frac{C}{\sqrt{1+\left(z / z_{R}\right)^{2}}}\left(\frac{r \sqrt{2}}{\omega(z)}\right)^{|m|} L_{p}^{m}\left(\frac{2 r^{2}}{\omega^{2}(z)}\right) \exp \left(-\frac{r^{2}}{\omega^{2}(z)}\right) \\
& \times \exp \left\{-i \frac{k r^{2} z}{2\left(z^{2}+z_{R}^{2}\right)}\right\} \exp (-i m \phi) \exp \left\{i(2 p+m+1) \tan ^{-1} \frac{z}{z_{R}}\right\}
\end{aligned}
$$

$L_{p}^{m}(x) \quad$ Laguerre polynominal, $\mathbf{m}$ is OAM value
$L_{0}^{m}(x)=1$

## Interference pattern: OAM = -1

Reference light


OAM light





## Interference pattern: OAM = -2

## OAM light



Interference


## OAM value is inverted. Why?

But, we can explain the spiral interference pattern. This is due to a finite curvature of the wave front.



## Interference pattern without lens



## Interference pattern w/o lens

OAM value



I cannot understand why the interference pattern become fork, but..

## Interference pattern w/o lens

If the beam intersects another beam at angle, alpha, Gaussian beam can be expressed as
$E=E_{0} \frac{\omega_{0}}{\omega(z)} \exp \left(-\frac{r^{2}}{\omega^{2}(z)}\right) \exp \left\{-i\left(k z \cos \alpha+k x \sin \alpha+k \frac{r^{2}}{2 R(z)}-\psi(z)\right)\right\}$
The term kxsin(alpha) induce fork interference pattern, and the pattern will change by the value of alpha.

## Changing crossing angle: OAM = -1



## Chaning crossing angle: OAM = -2



## What will happen if OAM laser injects

## Grating



## Interference pattern using double gratings



## Interference pattern

OAM G1 = -1
OAM G2 = -1


OAM G1 = -1
OAM G1 = -1
OAM G2 =0
OAM G2 =+1
$0 A M=-1$


Profile of the beam from G2


## Interference pattern

OAM G1 = -1
OAM G2 = -2

OAM = -3


OAM G1 = -1
OAM G1 = -1
OAM G2 = 0
OAM G2 = +2


## OAM

## Interference pattern

OAM G1 $=-2$
OAM G2 $=-1$
$0 A M=-3$


OAM G1 = -2
OAM G1 = -2
0AM G2 =+1


## Interference pattern

OAM G1 = +2 OAM G2 = -1

OAM = +1


OAM G1 = +2
OAM G1 = +2

OAM G2 = +1
OAM G2 = 0

## 0 MM $=+1$

$0 A M=+2$
$0 A M=+3$

## Interference pattern



OAM value is preserved.

## Interference pattern between OAM laser



## Interference pattern with reference laser

OAM value = -1: Right hand spiral interference is produced
0AM laser from G1 and reference laser (without G2)


OAM laser from G2 and reference laser (without G1)


OAM value from G2 is inverted.

## Interference pattern

OAM value (value of G2 is inverted from the actual value)

G1 = -1
G2 = +1



G1 = -1
G2 =-1



## Interference pattern

G1 $=-1$
G2 = -2




## Interference pattern



## Fabry Perot cavity with OAM Iaser



Self-mode-locked Laguerre-Gaussian beam with staged topological charge by thermal-optical field coupling

Y. Zhang et al., Opt. Exp., 245514 (2016).

## Hall A, C or Hall D?

## Hall A, C



Merit:
Low cost (polarimeter exists). Demerit:
Many restriction?

## Beam line to Hall D



Merit:
Free access.
Demerit:
High cost? (Laser injection
sysytem should be constructed.)

## Schedule



